

RECEIVED  
CENTRAL FAX CENTER

FEB 26 2007

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

*OK to enter  
mm  
3-6-07*

In re United States Patent Application of:	)	Docket No.: 2771-696
	)	(7486)
Applicants: HENDRIX, Bryan C. et al.	)	Conf. No.: 6889
Application No.: 10/803,750	)	Art Unit: 1762
Date Filed: March 18, 2004	)	Examiner: Stouffer, Kelly M.
Title: CHEMICAL VAPOR DEPOSITION OF HIGH CONDUCTIVITY, ADHERENT THIN FILMS OF RUTHENIUM	)	Customer No.: 25559

## FACSIMILE TRANSMISSION CERTIFICATE

ATTN: Examiner Kelly M. Stouffer

Fax No. (571) 273-8300

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission addressed to Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, and transmitted on February 26, 2007 to United States Patent and Trademark Office facsimile transmission number (571) 273-8300.

24

Number of Pages

Steven J. Hultquist

February 26, 2007

Date

RESPONSE TO JANUARY 26, 2007 ADVISORY ACTION IN U.S. PATENT  
APPLICATION NO. 10/803,750; PETITION UNDER 37 CFR 1.136 FOR ONE MONTH  
EXTENSION OF TIME

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

This responds to the January 26, 2007 Advisory Action in the above-identified application.

02/27/2007 TL0111 00000016 10003750

01 FC:1251

120.00 OP